Attorney Docket No. 108298515US1 Disclosure No. 00-0998.00/US

AMENDMENT TRANSMITTAL LETTER						Docket No. 108298515US1	
Applicatio		Filing Date		Examiner		Art Unit	
09/888,084-Conf. #8101		June 21, 2001		D. V. Nguyen		3723	
Applicant(s): Lee et al.							
Invention: METHODS AND APPARATUS FOR ELECTRICAL, MECHANICAL AND/OR CHEMICAL REMOVAL OF CONDUCTIVE MATERIAL FROM A MICROELECTRONIC SUBSTRATE							
TO THE COMMISSIONER FOR PATENTS							
Transmitted herewith is an amendment in the above-identified application.  The fee has been calculated and is transmitted as shown below.							
CLAIMS AS AMENDED							
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate			
Total Claims	124	- 126 =	0	х .			
Independent Claims	19	- 20 =	0	x			
Multiple Dependent Claims (check if applicable)							
Other fee (please specify): Information Disclosure Statement					180.00		
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:						180.00	
x Large Entity Small Entity							
No additional fee is required for this amendment.							
Please charge Deposit Account No in the amount of \$							
A duplicate copy of this sheet is enclosed.							
A check in the amount of \$ to cover the filing fee is enclosed.  Payment by credit card. Form PTO-2038 is attached.							
The Director is hereby authorized to charge and credit Deposit Account No50-0665							
as described below.							
x Credit any overpayment.							
Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.							
Jønn M. Wechk				Dated:	July 26	, 2005	
Attorney Reg. N	No.: 42,216	•					
PERKINS COIE LLP P.O. Box 1247 Seattle, Washington 98111-1247 (206) 359-8000							
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7-28-05

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Express Mail No. EV551885551US

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**PATENT** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF:

WHONCHEE LEE ET AL.

**APPLICATION NO.:** 

09/888,084

FILED:

For:

2 6 2005

JUNE 21, 2001

METHODS AND APPARATUS FOR

ELECTRICAL, MECHANICAL AND/OR CHEMICAL REMOVAL OF CONDUCTIVE

**MATERIAL FROM A** 

MICROELECTRONIC SUBSTRATE

EXAMINER: DUNG V. NGUYEN

ART UNIT: 3

3723

CONF. NO:

8101

## Amendment Under 37 C.F.R. § 1.111

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

The present communication responds to the Office Action dated April 26, 2005 in the above-identified application. Please amend the application as follows:

Amendments to the Claims are reflected in the listing of claims beginning on page 2.